

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
ODA et al.)
Application Number: To be Assigned)
Filed: Concurrently herewith)
For: SEMICONDUCTOR DEVICE AND)
MANUFACTURING METHOD)
Attorney Docket No. HITA.0474)
) **Art Unit 2811**
)

**Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231**

PRELIMINARY AMENDMENT

Sir:

Prior to an examination on the merits, please amend the above identified application as follows: